



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 13, 2026

IGI Report Number

LG789639971

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

HEXAGONAL STEP CUT

Measurements

7.68 X 6.64 X 4.30 MM

GRADING RESULTS

Carat Weight

1.51 CARAT

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

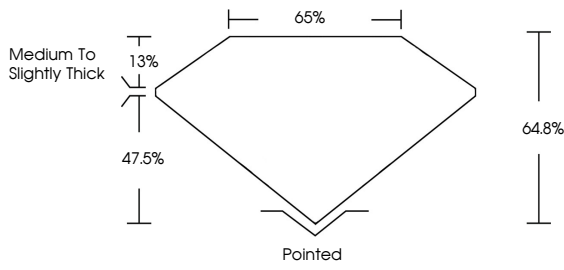
Inscription(s)

 LG789639971

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

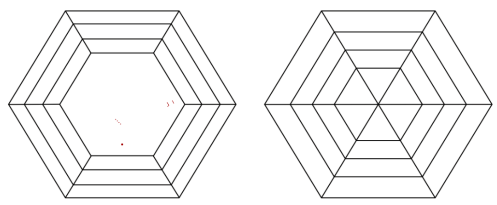
PROPORTIONS



Medium To Slightly Thick

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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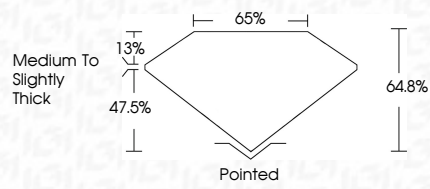
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HEXAGONAL STEP CUT

7.68 X 6.64 X 4.30 MM

Carat Weight

1.51 CARAT

Color Grade

E

Clarity Grade

VVS 2

Depth

47.5%

Table

65%

Girdle

Medium to Slightly Thick

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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